IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Applicant: Wenzel et al. Filed:

Herewith

For:

METHOD AND SYSTEM FOR ION BEAM CONTAINMENT USING

PHOTOELECTRONS IN AN ION BEAM GUIDE

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

1. Pursuant to 37 C.F.R. 1.97 and 1.98, and in compliance with 37 C.F.R. 1.56, the Office's attention is directed to the patents, pending applications, publications and other information listed on the attached PTO-1449. A copy of each listed document is enclosed except for: (a) pending applications or (b) those previously cited or submitted to the Office in the following application(s) upon which this application relies for an earlier filing date under 35 U.S.C. 120: Serial No.: ______ Filing Date:

Regarding any document, publication or other information for which a date is not given on the attached PTO-1449, Applicant(s) believe(s) the same may qualify as "prior" art to this application and should be treated accordingly, although Applicant(s) reserve(s) the right to contest the prior art status of any document, publication or information, should issue arise.

- 2. Regarding each listed document that is not in the English language, an English-language translation accompanies this Statement as indicated on the attached PTO-1449 or a concise explanation of the relevance of the document is set forth in the following document(s):
 - (a) ___ Copy of each English language version of a search report indicating the degree of relevance found by the foreign office of each document being submitted from the search
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 - 3. Pursuant to 37 C.F.R. 1.97(b) this Statement is being filed (one must be checked):
 - (a) X Within 3 months of the filing date or date of entry into the National Stage.
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 - (c) ____ Before the mailing date of a first Office Action on the merits after a first or second submission under 37 C.F.R. 1.129(a).

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	INFORMATIO	N DISCLOSURE		Filing Date			
		BY APPLICANT		First Named Inventor	Wenzel et al.		
	OTATEMENT	DI AIT LIOANI		Group Art Unit			
	(use as many sh	neets as necessary)		Examiner Name			
Sheet	1	of	2	Attorney Docket No.	02-IMP-076		

				U.S. PATENT	DOCUMENTS	<u> </u>
Exam.	Cite	U.S. Patent Docu	Kind Code ²	Name of Patentee or Applicant of	Date of Pub. of Cited Doc.	Pages, Columns, Lines, Where Relevant Passages or Relevan
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Examiner	Date
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.

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Sheet	2	of	2	Attorney Docket No.	02-IMP-076	

	FOREIGN PATENT DOCUMENTS									
Exam. Initials	Cite No. ¹	Office ³	Foreign Patent Docu Number ⁴	Kind Code ² (if known)	Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁸		
	ВА	JP	7-340297	KIIOWIII	Hitachi, K.K.	12/27/1995	Entire Document	Yes		
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		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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	CF				
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	CI				
	CJ				

Examiner	Date	
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